INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 4, 2026

IGI Report Number	LG830653754
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.91 - 7.94 X 4.74 MM

GRADING RESULTS

Carat Weight	1.80 CARAT
Color Grade	F
Clarity Grade	VS 1
Cut Grade	IDEAL

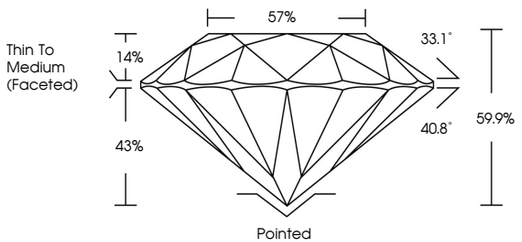
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG830653754

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG830653754
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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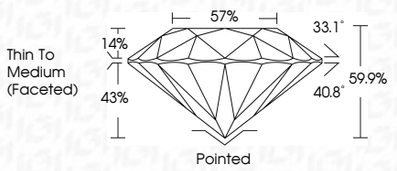
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www.igi.org

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ROUND BRILLIANT
7.91 - 7.94 X 4.74 MM
Carat Weight 1.80 CARAT
Color Grade F
Clarity Grade VS 1
Cut Grade IDEAL
Depth 59.9%
Table 57%
Girdle Thin To Medium (Faceted)
Culet Pointed
Polish VERY GOOD
Symmetry EXCELLENT
Fluorescence NONE
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Type IIa